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JUN 30 2006

ASMEX.433A

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Matthew G. Goodman, <i>et al.</i>
Application No.	:	10/775,522
Filed	:	February 10, 2004
For	:	TWO-STAGE LOAD FOR PROCESSING BOTH SIDES OF A WAFER
Examiner	:	Sylvia MacArthur
Group Art Unit	:	1763
Confirmation No.	:	1057

AMENDMENT UNDER 37 C.F.R. 1.114

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is responsive to an Office Action mailed March 31, 2006. A response filed by June 30, 2006 falls within the three-month shortened statutory period.

**Amendments to the Claims** are reflected in a listing of claims beginning on page 2 of this paper.

**Remarks** begin on page 6 of this paper.